

	Application No.	Applicant(s)	
Notice of Allowability	10/823,990	WANG ET AL.	
	Examiner	Art Unit	
	Andy Huynh	2818	~
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT I of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED 5) or other appropriate comm RIGHTS. This application is	in this application. If not included nunication will be mailed in due cou	rse. THIS
1. X This communication is responsive to the Amendment and	d Election dated 10/19/05.		• •
2. 🔀 The allowed claim(s) is/are <u>1-55</u> .			
 3. Acknowledgment is made of a claim for foreign priority of a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	ve been received.		
3. Copies of the certified copies of the priority d	ocuments have been receive	ed in this national stage application	from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:		• .	
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to fil MENT of this application.	e a reply complying with the requir	ements
4. A SUBSTITUTE OATH OR DECLARATION must be sub- INFORMAL PATENT APPLICATION (PTO-152) which gi	mitted. Note the attached EX ves reason(s) why the oath	AMINER'S AMENDMENT or NOT or declaration is deficient.	ICE OF
5. CORRECTED DRAWINGS (as "replacement sheets") me	ust be submitted.	•	
(a) I including changes required by the Notice of Draftspe	rson's Patent Drawing Revie	w (PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examine Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on the header according to 37 C	the drawings in the front (not the ba FR 1.121(d).	ck) of
 DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMENT 	osit of BIOLOGICAL MAT TFOR THE DEPOSIT OF B	ERIAL must be submitted. Note OLOGICAL MATERIAL.	e the
Attachment(s)	E □ Nation of I	oformal Datast Application (PTO 1	52 \
 Notice of References Cited (PTO-892) Dotice of Draftperson's Patent Drawing Review (PTO-948) 		nformal Patent Application (PTO-1 Summary (PTO-413),	<i>32)</i>
2. Notice of Dranperson's Patent Drawing Neview (F10-940)	Paper No	/Mail Date	
 Information Disclosure Statements (PTO-1449 or PTO/SB Paper No./Mail Date 01/03/05 	/08), 7. ☐ Examiner	s Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit	8. 🛭 Examiner'	s Statement of Reasons for Allowa	nce
of Biological Material	9. 🗌 Other		
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DETAILED ACTION

In the Amendment dated 10/19/2005, Claims 45-50 have been amended, and new Claim 55 is added.

Election/Restrictions

Claims 1-11 and 45-50 are directed to an allowable product. Pursuant to the procedures set forth in the Official Gazette notice dated March 26, 1996 (1184 O.G. 86), Claims 12-22 and 35-44, directed to the process of making or using the patentable product, previously withdrawn from consideration as a result of a restriction requirement, are now subject to being rejoined. Claims 12-22 and 35-44 are hereby rejoined and fully examined for patentability under 37 CFR 1.104.

Since all claims previously withdrawn from consideration under 37 CFR 1.142 have been rejoined, the restriction requirement made in the previous Office action is hereby withdrawn.

Accordingly, Claims 1-55 are pending in the application.

Allowable Subject Matter

Claims 1-55 are allowed.

The following is an examiner's statement of reason for allowance:

Claims 1-11 and 45-50 are allowable over the prior art of record because the prior art of record does not teach or render a Si/C superlattice useful for semiconductor devices comprises a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers as recited in independent Claim 1.

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Claims 12-44 and 51-54 are allowable over the prior art of record because the prior art of record does not teach or render a structure useful for electronic or opto-electronic devices comprises a Si/C superlattice comprising a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers, and in combination with all other features as recited in independent Claims 12, 23, 35 and 51.

Claim 55 is allowable over the prior art of record because the prior art of record does not teach or render a method for manufacturing low defect silicon carbide for use in semiconductor devices comprises providing a template consisting of a superlattice comprising a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers, and in combination with all other features as recited in the claim.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andy Huynh whose telephone number is (571) 272-1781. The examiner can normally be reached on Monday-Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for the

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organization where this application or proceeding is assigned are (571) 273-8300 for regular communications and (703) 872-9306 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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10/28/05

Andy Huynh

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Patent Examiner